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## BIB DATA SHEET

CONFIRMATION NO. 5980

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/582,860		117	1792	136164

## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP04/17192 11/18/2004

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-419202 12/17/2003

## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

02/18/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No					
Verified and	/FELISA CARLA HITESHEW/ Examiner's Signature	Initials	JAPAN	11	10	1
Acknowledged						

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## TITLE

Vapor phase growth apparatus and method of fabricating epitaxial wafer

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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